

## **Application Data Sheet**

---

### **Inventor Information**

Inventor One Given Name: Shuichi  
Family Name: KIKUCHI  
Residence: Ora-gun, Gunma, Japan  
Postal Address Line One: 30-6, Sumiyoshi  
Postal Address Line Two: Oizumi-machi, Ora-gun  
City: Gunma  
State or Province: Japan  
Postal or Zip Code:  
Citizenship Country: JAPAN

Inventor Two Given Name: Masaaki  
Family Name: MOMEN  
Residence: Ojiya-shi, Niigata, Japan  
Postal Address Line One: Chiyajimaryou  
Postal Address Line Two: 3030 Chiya koh  
City: Ojiya-shi  
State or Province: Niigata  
Postal or Zip Code:  
Citizenship Country: JAPAN

### **Correspondence Information**

Name Line One: Barry E. Bretschneider  
Name Line Two: Morrison & Foerster LLP  
Address Line One: 1650 Tysons Boulevard  
Address Line Two: Suite 300  
City: McLean  
State or Province: Virginia  
Postal or Zip Code: 22102  
Telephone: (703) 760-7743  
Fax: (703) 760-7777  
E-mail: bbretschneider@mofo.com

### **Application Information**

Title Line One: METHOD OF MANUFACTURING SEMICONDUCTOR  
DEVICE (AS AMENDED)  
Total Drawing Sheets: 5  
Formal Drawings?: yes  
Application Type: Utility  
Docket Number: 492322006510

### **Representative Information**

Representative Customer Number: 25227

### **Prior Foreign Applications**

**This Application is a Divisional of:**

Application Number:	10/215,188
Filing Date:	August 9, 2002

Prior Foreign Application One:	2001-243725
Filing Date:	August 10, 2001
Country:	Japan
Priority Claimed:	yes